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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10046497	FILING DATE 10/26/2001	CLASS 430 ²⁵⁷	SUBCLASS 288 ⁺	GAU 281 ²	EXAMINER THAO LE
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**APPLICANTS: Ping Er-Xuan; McKee Jeffrey;

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A DIV OF 09/816,962 03/23/2001

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** FOREIGN APPLICATIONS VERIFIED: No

PG-PUB <input type="checkbox"/>	DC NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO. MTI-31041-A
Verified and acknowledged Examiners's initials		
TITLE : Method for forming raised structures by controlled selective epitaxial growth of facet using spacer		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436 (Rev. 12-97)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg.
			Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner	
		Application Examiner	
		PREPARED FOR ISSUE	
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